

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Peter KOCHERSPERGER

Appl. No.: 10/780,877

Filed: February 19, 2004

**For: Overlay Correction By Reducing  
Wafer Slipping After Alignment**

Confirmation No.: 1990

Art Unit: 2822

Examiner: Duong, Khanh B.

Atty. Docket: 1857.2140000

**Comments on Statement of Reasons for Allowance**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

*Mail Stop: Issue Fee*

Sir:

Applicant thanks the Examiner for indicating the allowability of claims 12 and 24-38 in the Notice of Allowance dated June 24, 2010.

**Comments on Statement of Reasons for Allowance**

Applicant notes the Examiner's Statement of Reasons for Allowance presented on pages 3-4 of the Notice of Allowance. Applicant reserves the right to demonstrate claims 12 and 24-38 are allowable over the art made of record for further reasons related to any of their recited features. Applicant further contends that reservation of this right does not give rise to any implication regarding whether the Applicant agrees with or acquiesces in the reasoning provided by the Examiner.

Respectfully submitted,

STERNE, KESSLER, GOLDSTEIN & FOX P.L.L.C.

Jason D. Eisenberg  
Attorney for Applicant  
Registration No. 43,447

Date: 7/29/10

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